



**ELECTRONIC COPY**

LG744503756  
Report verification at igi.org



October 30, 2025

IGI Report Number **LG744503756**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **10.57 X 7.59 X 4.83 MM**

**GRADING RESULTS**

Carat Weight **4.09 CARATS**

Color Grade **G**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

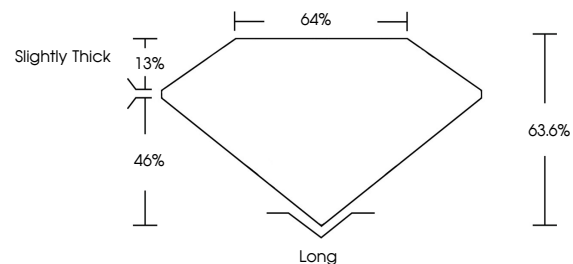
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG744503756**

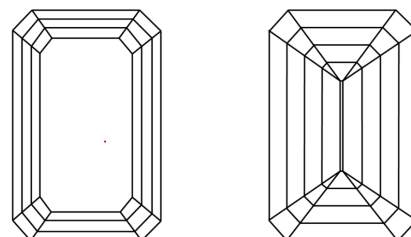
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

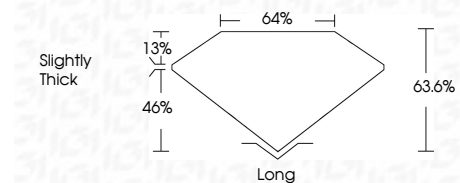
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



October 30, 2025	IGI Report No LG744503756	<b>EMERALD CUT</b>	<b>4.09 CARATS</b>	<b>G</b>	<b>VVS 2</b>	<b>63.6%</b>	<b>46%</b>	<b>Slightly Thick</b>	<b>Long</b>	<b>EXCELLENT</b>	<b>EXCELLENT</b>	<b>NONE</b>	<b>IGI LG744503756</b>
			Carat Weight	Color Grade	Clarity Grade	Table	Depth	Graile	Culet	Polish	Symmetry	Fluorescence	Inscription(s)

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